L #	Hits	Search Text	DBs	Time Stamp	Comments	Error Definition	Errors
L4	0	(epitaxial near4 semiconductor near4 layer) and (0.14 near density) and (0.05 near rms)	USPAT; US-PG PUB; EPO; JPO; DERW ENT; IBM_TD B; USOCR	2002/04/26 09:19			0
L5	0	(0.14 near density) and (0.05 near rms)	USPAT; US-PG PUB; EPO; JPO; DERW ENT; IBM_TD B; USOCR	2002/04/26 09:19			0
L6	0	l2 and l5	USPAT; US-PG PUB; EPO; JPO; DERW ENT; IBM_TD B; USOCR	2002/04/26 09:20			0

L #	Hits	S arch T xt	DB	Time Stamp	Comments	Error Definition	Err ors
L7	0	l2 and (0.14 near light near scatterers)	USPAT; US-PG PUB; EPO; JPO; DERW ENT; IBM_TD B; USOCR	2002/04/26 09:20			0
L8	0	(0.14 near light near scatterers)	USPAT; US-PG PUB; EPO; JPO; DERW ENT; IBM_TD B; USOCR	2002/04/26 09:24			0
L9	12	(("5254830") or ("5340437") or ("5567244") or ("5336355") or ("5290382") or ("4668366")).PN.	USPAT; EPO; JPO; DERW ENT; B; USOCR	2002/04/26 09:25			0
L10	6	(("5567244") or ("5336355") or ("5290382") or ("4668366")).PN.	USPAT	2002/04/26 09:26			0
L11	1	("5571373").PN.	USPAT	2002/04/26 09:27			0

L #	Hits	Search T xt	DBs	Tim Stamp	Comments	Error Definition	Err ors
L1	20	Photodetector and waveguide	USPAT; US-PG PUB; EPO; JPO; DERW ENT; IBM_TD B; USOCR	2002/04/26 09:15			0
L2	494 257/629		USPAT; US-PG PUB; EPO; JPO; DERW ENT; IBM_TD B; USOCR	2002/04/26 09:16			0
L	0	(semiconductor near wafer) and (epitaxial near4 semiconductor near4 layer) and (0.14 near density) and (0.05 near rms)	JPO; EPO; PUB; US-PG USPAT; DERW ENT; IBM_TD B; USOCR	2002/04/26 09:19			0

L #	Hits	Search T xt	DBs	Time Stamp	Comments	Error Definition	Err ors
L12	21	"5254830"	USPAT; US-PG PUB; EPO; JPO; DERW ENT; IBM_TD B	2002/04/26 09:28			0